



S/N 10/005667

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Qing Ma ✓

Examiner: Jamie L. Brophy

Serial No.: 10/005667 ✓

Group Art Unit: 2822

Filed: November 2, 2001 ✓

Docket No.: 884.591US1

Title: METHOD OF FABRICATING AN INTEGRATED CIRCUIT HAVING A
MEMS DEVICE

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicant has reviewed the Office Action mailed on May 23, 2003. Please amend the
above-identified patent application as follows.

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